

Form PTO-1449 U.S. DEPARTMENT OF COMMERCE (REV. 7-80) PATENT AND TRADEMARK OFFICE				Atty. Docket No. 13647A (BUR20000082US2)		Serial No. <u>10/801387</u> Unassigned	
LIST OF PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)				Applicant Wadgi W. Abadeer, et al.			
				Filing Date Herewith		Group Unassigned <u>2829</u>	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL*	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (if appropriate)	
✓	AA	5,945,834	8/31/99	Nakata, et al.			
	AB	5,898,629	4/27/99	Beffa, et al.			
	AC	5,831,445	11/3/98	Atkins, et al.			
	AD	5,661,408	8/26/97	Kamieniecki, et al.			
	AE	5/625,297	4/29/97	Arnaudov, et al.			
	AF	5,600,257	2/4/97	Leas, et al.			
	AF	5,578,930	11/26/96	Sheen			
	AH	5,570,032	10/19/96	Atkins, et al.			
	AI	5,552,704	9/3/96	Mallory, et al			
	AJ	5,528,159	6/18/96	Charlton, et al.			
	AK	5,519,193	5/21/96	Freiermuth, et al.			
	AL	5,489,974	5/12/96	Verkuil, et al.			
	AM	5,489,538	2/6/96	Rostoker, et al.			
	AN	5,485,091	1/16/96	Verkuil			
	AO	5,442,297	8/15/95	Verkuil			
	AP	5,440,241	8/8/95	King, et al.			
	AQ	5,412,328	5/2/95	Male, et al.			
	AR	5,424,651	6/13/95	Green, et al.			
	AS	5,399,101	3/21/95	Campbell, et al.			
✓	AT	5,429,520	7/4/93	Morlion, et al.			
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
✓	"WAFER LEVEL TEST AND BURN IN", <u>IBM Technical Disclosure Bulletin</u> , January 1992, pp. 401-404;						
✓	"MULTI-LAYER CERAMIC SPACE TRANSFORMER FOR WAFER LEVEL STRESS", <u>IBM Technical Disclosure Bulletin</u> , April 1999, pp. 385 - 386;						
✓	"WAFER BURN-IN ISOLATION CIRCUIT", <u>IBM Technical Disclosure Bulletin</u> , November 1989, pp. 442-443						
EXAMINER <u>W. H. Nguyen</u>				DATE CONSIDERED <u>10/14/06</u>			
* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							